

Form PTO-1449

INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION

Docket Number 4161-A12	Application Number <i>10/215165</i>
Applicant SHIEH	
Filing Date	Group Art Unit

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE
DN/L	5,034,958	23JUL91	KWON ET AL			
NML	5,245,622	14SEP93	JEWELL ET AL			
NNL	6,169,756	02JAN01	CHIROVSKY ET AL			
NNL	6,493,368	20DEC02	CHIROVSKY ET AL			

## FOREIGN PATENT DOCUMENTS


## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Dates, Etc.)


EXAMINER	DATE CONSIDERED
<i>Kang, Donghee</i>	<i>01-03-05</i>

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the application.